IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Takuji HIMENO et al.

International Application No.:

PCT/JP03/08433

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Sir:

Enclosed are copies of the publications, which were cited in the International Search Report of International Application No. PCT/JP03/08433. Also enclosed is a copy of Form PTO-1449 and the International Search Report.

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REMARKS

Entry of this Information Disclosure Statement and an early examination on the merits are respectfully solicited.

Please charge any additional fees to Deposit Account No. 50-0320.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP Attorneys for Applicants

William S. Frommer Reg. No. 25,506

Tel. (212) 588-0800

Enclosures



Sheet 1 of 1

Based on Form PTO-1449 (3/90)	ATTY. DOCKET NO. 450100-04678	SERIAL NOD 1520 2 4		
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